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Application of Ferroelectric Thin Films in MEMS

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Deadline for manuscript submissions:

closed (20 September 2022)

Message from the Guest Editors

Papers are invited in the following areas related to this topic:

- Growth and characterization of ferroelectric thin films for MEMS;
- Functional properties (piezoelectric, pyroelectric, dielectric, electro-optic etc) of ferroelectric thin films for MEMS;
- Processing of ferroelectric thin film MEMS devices;
- Piezoelectric MEMS actuators and sensors:
- Piezoelectric microfluidics:
- Thin film piezoelectric devices such as FBAR and SMR;
- Thin film piezoelectric resonant sensors;
- Piezoelectric MEMS ultrasound devices for use in air and aqueous environments;
- Thin film pyroelectric infra-red detectors and energy recovery devices;
- Thin film electrocaloric devices;
- Ferroelectric MEMS optical devices;
- Theory of ferroelectric thin film MEMS materials and devices













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Message from the Editor-in-Chief

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